

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

COMMENTARY RE INFORMATION DISCLOSURE STATEMENT

Applicant: Naoki MAKITA	
Application No.: 10/734,312	
Confirmation No.: 1687	Art Unit: 2815
Filing or 371(c) Date: December 15, 2003	Examiner: D. Richards
Title: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME	

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, submitted herewith are copies of four (4) references cited in the enclosed Official Communication issued in a corresponding Japanese Patent Application. For the Examiner's convenience, we have enclosed an English translation of the Japanese Official Communication from the corresponding Japanese Patent Application and a completed Form PTO/SB/08a.

Although the Official Communication cites three additional Japanese references, (JP 2002-329668, JP 2002-231958, and JP 10-125927) Applicant does not enclose a copy of these references herewith as the U.S. equivalent ( US 2002/0127827, US 2002/0102823, and US 2002/0100937) of these references were previously cited by the Examiner.

The statement is not a representation that all of the information cited is necessarily effective as prior art against the application.

Applicant respectfully requests that the cited references be made of record in the subject application.

Respectfully submitted,

Date: September 22, 2006

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